

Method and Apparatus for Semi-Solid Material Processing

Disclosure Number

200401372

Technology Summary

A method and apparatus for semi-solid material processing includes special timing and vibration equipments and methods of use.

Inventor

HAN, QINGYOU
Metals & Ceramics Division

Licensing Contact

DETRANA, ALEXANDER G
UT-Battelle, LLC
Oak Ridge National Laboratory
Rm 139, Bldg 4500N, MS: 6196
1 Bethel Valley Road
Oak Ridge, TN 37831

Office Phone: (865) 576-9682

E-mail: DETRANAAG@ORNL.GOV

Note: The technology described above is an early stage opportunity. Licensing rights to this intellectual property may be limited or unavailable. Patent applications directed towards this invention may not have been filed with any patent office.